

Notice of References Cited			Application/Control No. 09/810,333	Applicant(s)/Patent Under Reexamination BEHIN ET AL.	
			Examiner Tamai IE Karl	Art Unit 2834	Page 1 of 1

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	C	US-6253612	07-2001	Lemkin et al.	73/504.02
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	V	Translation of JP 4-343318, 11/1992
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.